



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 13, 2026	
IGI Report Number	LG782629100
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.42 - 7.46 X 4.41 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	EXCELLENT

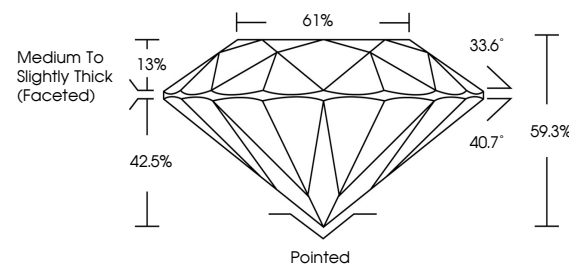
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG782629100

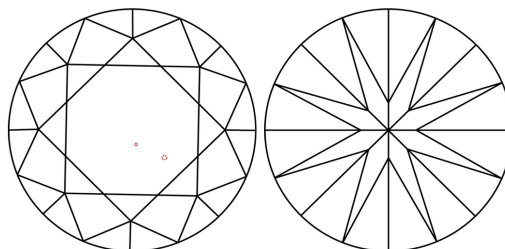
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG782629100
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

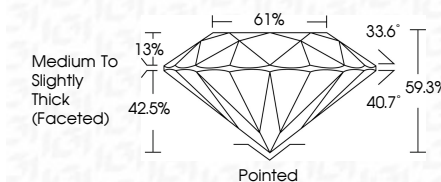
LABORATORY GROWN DIAMOND REPORT



March 13, 2026	
IGI Report Number	LG782629100
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.42 - 7.46 X 4.41 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	EXCELLENT



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES

www.igi.org

March 13, 2026	GL Report No. LG762629100	1.50 CARAT	D
ROUND BRILLIANT			VS 1
			EXCELLENT
			59.3%
			61%
			Medium to Slightly Thick (Faceted)
			Polished
			EXCELLENT
			NONE
			1651 LG762629100

Comments: Natural Color Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA